## PATENT APPLICATION

Docke Number: 081468-0306882 Client Reference: P-1741.000-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Fe the Application of Book STREEFKERK et al. Application No.: 10/719,683

Group Art Unit:

Examiner: Unassigned

Filed: November 24, 2003

Confirmation No.: Unassigned

For: Lithographic Apparatus and Device Manufacturing Method

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.56, the attention of the Patent and Trademark Office is hereby directed to the following U.S. patent application(s):

Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
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	Joeri LOF et al.	10/705,805	11/12/2003	Specification     Spe
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	Joeri LOF et al.	10/705,783	11/12/2003	Specification     Spe
				☐ Drawings
	Helmar VAN SANTEN et	10/743,271	12/23/2003	Specification     ■
	al.			☑ Drawings
				Other: stamped receipt card
	Johannes C.H.	10/743,266	12/23/2003	Specification     ■ Control of the control
	MULKENS et al.			☑ Drawings
	Antonius T.A.M.	10/705,785	11/12/2003	Specification
	DERKSEN et al.			□ Drawings     □
				○ Other: stamped receipt card
	Klaus SIMON et al.	10/724,402	12/01/2003	Specification
				☑ Drawings
				○ Other: stamped receipt card
	Joeri LOF et al.	10/705,816	11/12/2003	Specification     ■
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				Other: stamped receipt card
	Arno J. BLEEKER	10/715,116	11/18/2003	Specification     ■ Specification
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,				Other: stamped receipt card
	Joannes T. DeSMIT et	10/705,804	11/12/2003	Specification
	al.			☑ Drawings
	<u> </u>			☐ Other: stamped receipt card

<sup>\*</sup>The Examiner's initials adjacent a citation indicates he/she has considered the cited application relative to the subject application.

Let it is respectfully requested that these applications and the art cited therein during examination be expressly considered during the prosecution of this application and be made of record in this application. The identification of the above U.S. patent applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent.

<u>PLEASE DO NOT PRINT</u> the above information on the patent which results from this application.

Consideration of each listed application is earnestly solicited since unpublished patent applications are contemplated as IDS material; see the exception in Rule 98(a)(2)(iii) and note the penultimate sentence of MPEP 609.

Further, in keeping with MPEP 609, subsec. C(2), 2nd para., line 10 to end of the paragraph (especially note lines 18-25) **PLEASE <u>RETURN</u> A COPY OF <u>THIS LETTER</u>** with the Examiner's initials adjacent each above listing so that applicant will know that each listed application has been considered as required by PTO policy.

Secondly, please consider each enclosed document which is listed on the attached Form PTO-1449 and return a copy of that form with the Examiner's initials adjacent each citation. It is respectfully requested that these documents listed on the Form PTO-1449 be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

Jean-Paul G. Hoffmah Registration Number 42663 Customer Number: 00909

Date: February 20, 2004

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